## Notice of References Cited Application/Control No. 10/595,107 Applicant(s)/Patent Under Reexamination HAMAMATSU ET AL. Examiner C. Melissa Koslow 1793 Applicant(s)/Patent Under Reexamination HAMAMATSU ET AL.

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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

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